# The enhancement on optical attenuation by a tunable non-smooth mirror

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# ABSTRACT

Here the attenuation effect of a variable optical attenuator (VOA) with a tunable non-smooth mirror is investigated experimentally and analytically. The working principle of this VOA is based on the non-uniform deformation shape of a mirror membrane by thermally driven bimorph actuators. Before deformation, the surface roughness of Rymax and insertion loss of the mirror membrane are calibrated as 15 nm and 0.53 dB, respectively. The attenuation tests on smooth and non-smooth concave mirrors are also conducted. In simulation, the attenuation effects by various smooth spherical shapes are modeled by ray tracing method and Gaussian beam theory, and the simulation results are compared with experimental data. It is found that the attenuation behaviors between simulation and calibration results on smooth, spherical concave mirrors have good agreement. Also, by comparing the experimental results from smooth and non-smooth concave mirrors, the attenuation is found to be enhanced by the non-smooth mirror surface evidently. The maximum dynamic range of attenuation is found to be more than 40 dB at input voltage of 46 V.

# Keywords: enhancement attenuation, non-smooth mirror, transmission matrix, optical component, MEMS

### 1. INTRODUCTION

Lately, the optical attenuator has attracted lots of attentions in MEMS for its applications in optical communication. One of the popular approaches on MEMS optical attenuators is based on the sliding mirror mechanisms <sup>1-3</sup>. This type of attenuators can provide the optical attenuation higher than 57 dB<sup>-1</sup>. However, the insertion loss is also higher than 1.5 dB<sup>-1</sup>. Another approach is based on a tilting mirror <sup>4, 5</sup> or mechanical antireflection switch (MARS) <sup>6</sup> by modulating the light transmitted through the optical components. Liquid crystal is also used to attenuate the light power without moving parts <sup>7</sup>, which can provide faster response time than the sliding mirror type. The dynamic range of attenuation was less than 30 dB<sup>-6</sup>.

In this work, a new approach is proposed to attenuate the light power by using a tunable non-smooth concave mirror to act as a variable optical attenuator (VOA). The smooth flat mirror surface can provide a low insertion loss before deformation. Furthermore, the non-smooth mirror surface after deformation is expected to enhance the optical attenuation under a similar mirror curvature.

# 2. CONCEPT DESIGN OF THE VOA WITH A TUNABLE NON-SMOOTH MIRROR MEMBRANE

Figure 1 shows the side view of the proposed VOA with a tunable mirror membrane by thermally driven bimorph actuators. This VOA is fabricated by combining surface micromachining and back-side etching techniques, where the back-side of membrane is sputtered with gold to act as the mirror surface  $^{8}$ .

480

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Figure 2(a) shows the fabrication results of the flat reflecting mirror made of gold before deformation, where the SiN layer with bimorph actuators are underneath. The surface roughness, Rymax and Ra, are calibrated as 15 nm and 3 nm, respectively. When the bimorph actuators are electrically heated, the mirror becomes a non-smooth concave shape under different input voltages, as shown in Figure 2(b) and Figure 2(c). The deflections at the central mirror membrane are also calibrated under different input voltages, as shown in Figure 3, by a Laser Confocal Displacement Meter (KEYENCE Co., LT 8110). Four bimorph beams are applied with the same voltage simultaneously. When the input voltage is above 22 V, the mirror membrane starts to deflect, and evident deformation starts from 36 V.



Figure 1. Cross-section view of a VOA with a tunable non-smooth mirror.



Figure 2. Photos of deformed mirror membrane and four embedded bimorph beams at different input voltages. (a) A flat mirror at 0 V; (b) A concave shape mirror at 36 V; (c) A non-smooth concave shape mirror at 46 V.



Figure 3. Deflections at the central of the mirror membrane.

# 3. SIMULATION OF A SMOOTH SPHERICAL MIRROR

In order to verify the enhancement effect of the tunable non-smooth mirror, the simulation on a smooth spherical mirror is performed first. The relationship of light rays at different locations between two optical fibers can be modeled by ray tracing method, whose dimensions with hundreds of micrometer are much larger than the wavelength of 1.55  $\mu$ m. Also, according to the Gaussian beams theory, the width of light beam at cross section area of optical fiber propagates through optical components can also be modeled for a smooth spherical mirror <sup>9, 10</sup>.

The optical paths between two sides of an optical component are modeled by the transmission matrix, T, as:

$$\begin{bmatrix} r_2 \\ \theta_2 \end{bmatrix} = T \begin{bmatrix} r_1 \\ \theta_1 \end{bmatrix},\tag{1}$$

where the indexes, 1 and 2, mean two sides of an optical component at light axis, and  $r_1$ ,  $r_2$ ,  $\theta_1$ , and  $\theta_2$  represent the location and direction of light rays.

As shown in Figure 4, the optical path starts from the optical fiber 1, passes through free space 1, GREN lens, free space 2, reflecting mirror, then reflects back to optical fiber 2 in reverse way. The GREN lens and two single mode optical fibers together are also called the dual fiber collimator. The transmission matrices for free space 1, free space 2, and reflecting mirror are denoted by  $T_{f1}$ ,  $T_{f2}$ , and  $T_m$ , respectively, as expressed in Eq. (2). Furthermore,  $T_g$  is the transmission matrix of GRIN lens.

482 Proc. of SPIE Vol. 5116



Figure 4. Schematic diagram of the modeling optical attenuator with the smooth concave mirror.



The  $d_1$  and  $d_2$  represent the distance of free space 1 and 2, respectively. The  $R_m$  represents the radius curvature of concave mirror. The transmission matrix of the system, T, represents the light beam passing through a sequence of optical components from optical fiber 1 to optical fiber 2, and can be expressed as Eq. (3).

$$T = T_{f1} T_g T_{f2} T_m T_{f2} T_g T_{f1}$$
(3)

The attenuation from optical fiber 1 to optical fiber 2 is expressed in Eq. (4), where the  $w_1$  and  $w_2$  represent the width of light beam at crose section of fiber 1 and fiber 2, respectively. The relationship of the  $w_1$  and  $w_2$  can also be computed by the transmission matrix of system, T<sup>9</sup>.

$$Loss = -20 \log \left(\frac{2w_1 w_2}{w_1^2 + w_2^2}\right)^2$$
(4)

#### 4. ATTENUATION TEST

In order to calibrate the attenuation, the calibration facilities are set up. Figure 5 shows the schematic diagram of the experimental setup in attenuation measurement, including a laser diode, a reflecting mirror, a power meter, and a dual fiber collimator with two optical single mode fibers. The laser diode can generate light power at wavelength of  $1.55 \,\mu\text{m}$ . The power meter can detect the power change of the reflected light. The dual fiber collimator can collimate the light

Proc. of SPIE Vol. 5116 483

beam, then the parallel light beam can be emitted into the mirror and be reflected to the power meter. The insertion loss of the dual fiber collimator is given as 0.21 dB by the manufacturer.

In attenuation test, a series of smooth spherical concave mirrors with different radius curvature are tested first, as shown in Figure 5(a). Then, the attenuations by the tunable non-smooth mirror at different input voltages are calibrated, as shown in Figure 5(b).

Figure 6 shows the dynamical optical attenuation of the proposed tunable non-smooth mirror under different input voltages. The input voltage in testing is increased from 0 V to 46 V gradually. Each data point represents the average of ten different tests in steady state with the same sample. The attenuation effect can be observed when input voltage is above 34 V. The 30 dB attenuation, which is the typical requirement on attenuators, can be achieved around 44 V. The maximum dynamic range is higher than 40 dB when the input voltage is 46 V.



Figure 5. The schematic diagram of experimental setup in attenuation measurement. (a) A series of smooth spherical concave mirrors with different radius curvature; (b) A reflecting mirror of the proposed VOA.

484 Proc. of SPIE Vol. 5116



Figure 6. Calibrated attenuation at different input voltages of the proposed VOA with a tunable non-smooth mirror.

# 5. COMPARISON OF SIMULATION AND CALIBRATION RESULTS

In order to simulate the attenuation effect by the smooth spherical mirrors, the parameters in transmission matrices of Eq. (2) needs to be determined first. By direct measurement,  $d_1$  and  $d_2$  are found to be 0.242 mm and 0.25 mm, respectively. The range of  $R_m$  is from 1 mm to 200 mm. Therefore, the  $T_{f1}$ ,  $T_{f2}$ , and  $T_m$ , can be determined, and  $T_g$  is given by the manufacturer. The  $w_1$  at the cross section of a single mode optical fiber is 5  $\mu$ m.

The simulation and experimental results of smooth spherical concave mirrors with different radii of curvature are both shown in Figure 7 with good agreement, where the black line represents the simulation results and the square mark, represents the calibrated results.

If the reflecting mirror of the proposed VOA is assumed to deform in a spherical concave shape, the corresponding radius of curvature can be calculated by calibrating the relative displacements between the central membrane and the end of bimorph actuators, since the horizontal distance between central point of the membrane and the end of the bimorph actuators are known. Then the attenuations by the tunable non-smooth mirror membrane can be expressed in terms of the radius of curvature, also shown in Figure 7, which is denoted with the triangle mark.



Figure 7. Calibrated and simulate attenuation effects different mirror curvature.

It is found that, for example, when the radius of curvature of mirror is 50 mm, the non-smooth mirror can provide about 5 dB more attenuation than the smooth one can achieve. It indicates that the attenuation effect can be enhanced by non-smooth mirror surface of this VOA design.

# 6. SUMMARY AND CONCLUSION

A VOA with a tunable non-smooth mirror is proposed, fabricated and tested here. From experimental results, the SiN membrane coated with Cr/Au is found to be flat enough to provide insertion loss of 0.53 dB before deformation. The thermal bimorph membrane actuator is shown to be able to deform the mirror up to 16  $\mu$ m at the central mirror membrane at 44 V, even the deformed membrane is not smooth. In simulation, the attenuation by smooth spherical mirrors with different curvatures are computed. Furthermore, a series of smooth spherical concave mirrors with different radii of curvature are also tested to verify the above simulation results. By comparing the experimental data between smooth and non-smooth mirror surfaces, it also verifies that the attenuation can be enhanced by non-smooth effect. The dynamic range of the proposed attenuator is more than 40 dB at input voltage of 46 V.

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486 Proc. of SPIE Vol. 5116

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